AUG 0 7 2002 APPLICATION NO. ATTY DOCKET NO. 0171-0826P Form PTO-1449 10/082,315 APPLICANT INFORMATION DISCLOSURE FUKUOKA, Hirofumi et al. IN AN APPLICATION FILING DATE (Use several sheets if necessary) 1755 August 7, 2002 U.S. PATENT DOCUMENTS FILING DATE
IF APPROPRIATE CLASS NAME DATE DOCUMENT NUMBER EXAMINER INITIAL Fukuoka et al. **み**35 2001-08-09 2001/0012503 A1 FOREIGN PATENT DOCUMENTS TRANSLATION COUNTRY CLASS DOCUMENT NUMBER EP 1998-05-06 0 840 386 A 1987-04-01 EP 0 216 649 A M OTHER DOCUMENTS (Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine coursel, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published. DATABASE WPI, Section Ch, Week 200207 Derwent Publications Ltd., London, GB; Class L02, AN 2002-051162 XP0022011234 JP 2001 226112 A (SHINETSU CHEM IND CO LTD), 21 August 2001 (2001-08-21) *abstract* DATABASE WPI, Section Ch, Week 200163 Derwent Publications Ltd., London, GB; Class E36, AN 2001-560341 XP002201124 & JP 2001 158613 A (DENKI KAGAKU KOGYO KK), 12 June 2001 (2001-06-12) *abstract* DATABASE WPI, Section Ch, Week 200158 Derwent Publications Ltd., London, GB; Class L03, An 2001-524965 XP002201125 & JP 2001 118568 A (DENKI KAGAKU KOGYO KK), 27 April 2001 (2001-04-27) *abstract* PATENT ABSTRACTS OF JAPAN, Vol. 2000, No. 24, 11 May 2001 (2001-05-11) & JP 2001 185125 A (DENKI KAGAKU KOGYO KK), 6 July 2001 (2001-07-06) *abstract* Ym PATENT ABSTRACTS OF JAPAN, Vol. 2000, No. 24, 11 May 2001 (2001-05-11) & JP 2001 199716 A (DENKI KAGAKU KOGYO KK), 24 July 2001 (2001-07-24) *abstract* DATABASE CA 'Online! CHEMICAL ABSTRACTS SERVICE, COLUMBUS, OHIO, US; ECKERT, HANS J. et al.: "Studies on silicon oxides" retrieved from STN database accession no. 86:46630 CA XP002201140 *abstracts* & WISS. Z., TECH. HOCHSCH., KARL-MARX STADT (1976), 18(1), 103-12, 1976 DATE CONSIDERED 11/28/03 EXAMINER When when which

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